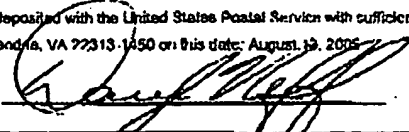


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I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: MS AF, Commissioner for Patents, Alexandria, VA 22313-1450 on this date: August 13, 2005

Name of Depositor: **Daryl K. Neff** Signature: 

*Please enter  
 KP (9/16/05)*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE	
In re application of: <b>Michael P. Belyansky, et al.</b>	Date: <b>August 13, 2005</b>
Serial Number: <b>10/605,889</b>	Examiner: <b>Long Pham</b>
Filed: <b>November 4, 2003</b>	Group Art Unit: <b>2814</b>
Title: <b>OXIDATION METHOD FOR ALTERING A FILM STRUCTURE AND CMOS TRANSISTOR STRUCTURE FORMED THEREWITH</b>	IBM Corporation D/18G, B/300, Zip 482 2070 Route 52 Hopewell Junction, NY 12533-8531

**AMENDMENT**

MS AF  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

Dear Sir:

In response to the final Office Action dated August 9, 2005, Applicants submit the following amendments and remarks.

**FIS920030286US1**